

PATENT

Atty. Dkt. No. AMAT/5262/CMP/CMP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Tsai, et al.

Serial No.: 09/961,134

Confirmation No.: 4110

Filed: September 21, 2001

For: Method and Apparatus For
Forming Metal Layers

Group Art Unit: 1753

Examiner: Wong, Edna

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I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 703-872-9306 to the attention of the named Examiner, on the date below.

May 19, 2004

Date

Signature

Dear Sir:

SECOND RESPONSE TO FINAL OFFICE ACTION DATED FEBRUARY 6, 2004

In further response to the Final Office Action dated February 6, 2004, having a shortened statutory period for response extended by appeal to July 10, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5262/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

The pending claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 3 of this paper.

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